



PATENT APPLICATION

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re the Application of:

Confirmation No.: 9442

KIRIMURA et al.

Art Unit: 1722

Application No.: 09/822,414

Examiner: M. Song

Filed: April 2, 2001

Attorney Dkt. No.: 107351-00011

For: FILM FORMING APPARATUS AND METHOD OF FORMING A CRYSTALLINE
SILICON FILM

RESPONSE TO FINAL REJECTION UNDER 37 C.F.R. §1.116

MAIL STOP AF

Commissioner for Patents

P.O. Box 1450

Alexandria, Virginia 22313-1450

Sir:

November 2, 2005

In reply to the Office Action dated June 2, 2005, the period for response being extended from September 2, 2005 to November 2, 2005, by the attached Petition For Extension of Time, please amend the above-identified application as set forth below.

Amendments to the claims begin on page 2.

Remarks begin on page 12.